## IN THE CLAIMS:

1. (Currently Amended) Method A method of producing nanostructures in membranes, in which comprising the steps of:

<u>irradiating</u> a membrane consisting of a polymer material is irradiated with charged particles, especially ions, to produce particle tracks,;

etching the particle tracks of the membrane are etched using with an etching liquid; and

stopping the etching operation is stopped using with a stop liquid, such that asymmetrical structures are formed;

in such a manner that asymmetrical structures are formed,
wherein polyimide is used as the membrane material said polymer material is a polyimide.

- 2. (Currently Amended) Method The method according to claim 1, wherein the polyimide used is Kapton is comprised of aromatic rings.
- 3. (Currently Amended) Method The method according to claim 1, wherein the etching liquid used is a NaOCl solution.
- 4. (Currently Amended) Method The method according to claim 1, wherein the stop liquid used is a reducing agent.

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- 5. (Currently Amended) Membrane A membrane having asymmetrical pores, consisting of polyimide and produced in accordance with the method according to of claim 1.
- 6. (New) The method according to claim 4, wherein the reducing agent is a solution of the redox type comprising KI,  $NO_2^-$ ,  $S_2O_3^-$  or  $Mn^{2+}$ .